



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2851 Examiner: Hung Nguyen

In Re PATENT APPLICATION of:

Applicant(s): Ryoichi AOYAMA et al.

Serial No.: 10/748,240

Filing Date: December 31, 2003

For:

SELF-CLEANING METHOD FOR

SEMICONDUCTOR EXPOSURE

APPARATUS

Atty. Dkt.:

OKI 395

AMENDMENT

April 4, 2005

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on January 5, 2005, please amend the above-identified application as follows:

FEE ENCLOSED:\$ Please charge any further fee to our Deposit Account No. 18-0002